



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. .... 10/655,997  
Filing Date ..... September 5, 2003  
Inventor ..... Jon P. Daley  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2822  
Examiner ..... Pamela E. Perkins  
Attorney's Docket No. .... MI22-2380  
Customer No. .... 021567  
Title: Methods of Forming Patterned Photoresist Layers Over Semiconductor  
Substrates

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References - See Attached Form PTO-1449

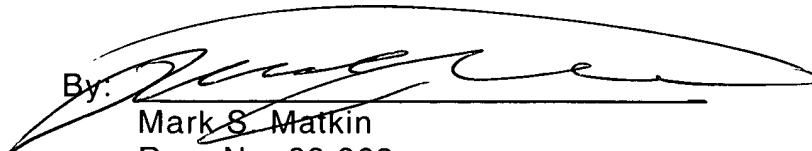
The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated: 3-16-06

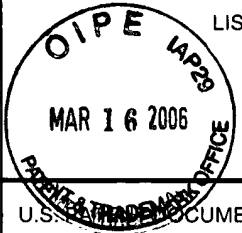
By:   
Mark S. Matkin  
Reg. No. 32,268

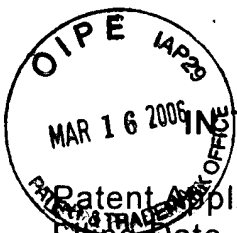
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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2380		SERIAL NO. 10/655,997	
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT: Jon P. Daley			
				FILING DATE September 5, 2003		GROUP ART UNIT 2822	
U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,838,363	01/05	Wieczorek et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AJ						
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
EXAMINER		DATE CONSIDERED					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							



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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**


References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first office action after the filing of a Request for Continued Examination. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 12-1-05

By:   
Mark S. Matkin  
Reg. No. 32,268

**EV633200332**  
**EV633262561**

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-2380SERIAL NO.  
10/655,997LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)

APPLICANT: Jon P. Daley

FILING DATE  
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2822

## U.S. PATENT DOCUMENTS

*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	3,772,101	11/1973	Chumbres et al.			
	AB	5,677,102	10/1997	Shihara			
	AC	6,096,634	08/2000	Nguyen			
	AD	6,165,834	12/2000	Agarwal et al.			
	AE	6,188,097	02/2001	Derderian et al.			
	AF	6,238,994	05/2001	Derderian et al.			
	AG	6,255,035	07/2001	Minter et al.			
	AH	6,297,527	10/2001	Agarwal et al.			
	AI	6,376,149	04/2002	Grober et al.			

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
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	AL							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

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U.S. PATENT DOCUMENTS							
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,399,982	06/2002	Derderian et al.			
	AB	6,511,896	01/2003	Basceri et al.			
	AC	6,608,343	08/2003	Derderian et al.			
	AD	6,617,250	09/2003	Basceri et al.			
	AE	6,649,466	11/2003	Basceri et al.			
	AF	6,744,093	06/2004	Agarwal et al.			
	AG	6,746,916	06/2004	Agarwal et al.			
	AH	6,777,739	08/2004	Agarwal et al.			
	AI	6,780,766	08/2004	Basceri et al.			

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U.S. PATENT DOCUMENTS							
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,817,086	11/2004	Lu et al.			
	AB	6,900,497	05/2005	Agarwal et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
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